




FORM PTO-1449 (SUBSTITUTE) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT (37 CFR 1.98(b))				Attorney Docket No.: MUH-12807 Appl. No.: _____ Applicant: HAGEN KLAUK ET AL. Filing Date: October 6, 2003 Group Art Unit: _____			
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EXAMINER INITIALS	A	PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
RD	A	4,588,609	5/13/86	Leyden et al.	_____	_____	_____
RD	B	4,910,149	3/20/90	Okube et al.	_____	_____	_____
RD	C	5,447,824	9/5/95	Mutsaers et al.	_____	_____	_____
RD	D	5,250,388	10/5/93	Schoch, Jr. et al.	_____	_____	_____
RD	E	5,942,374	8/24/99	Smayling	_____	_____	_____
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		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES NO
RD	J	04356931 A	12/10/92	Japan	_____	_____	
RD	K	0 399 299 A2	11/28/90	Europe	_____	_____	
RD	L	97/39383	10/23/97	WIPO	_____	_____	
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
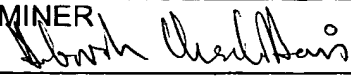
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RD	Pichler, K. et al.: "Field-Effect Transistors Based on Poly (p-Phenylene Vinylene) Doped by Ion Implantation", American Institute of Physics, Journal of Applied Physics, Vol. 77, No. 7, April 1, 1995, pp. 3523-3527
EXAMINER <i>Donald H. Davis</i>	DATE CONSIDERED 03/11/06



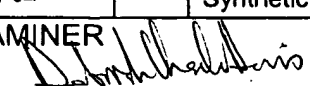
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